

STP 1001  
OCT 12 2007  
PATENT & TRADEMARK

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Dated: October 9, 2007

Signature

(Andrew T. Zidel)

EXPEDITED PROCEDURE  
Group Art Unit: 2116  
Docket No.: SCEI 3.0-200

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: :  
: :  
Keisuke Inoue :  
: :  
Application No.: 10/812,155 : Group Art Unit: 2116  
: :  
: :  
Filed: March 29, 2004 : Examiner: S. Stoynov  
: :  
For: METHODS AND APPARATUS FOR :  
ACHIEVING THERMAL MANAGEMENT :  
USING PROCESSOR MANIPULATION :  
:

AMENDMENT PURSUANT TO 37 C.F.R. § 1.116

MS AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated June 13, 2007, finally rejecting claims 15-19 and 37-51, please amend the above-identified U.S. patent application as follows: